

| <p style="text-align: center;">EXAMINER'S ART CITATION <small>(Use several sheets if necessary)</small> MAR 19 2007 <small>TRADEMARKS</small></p> | Application 10/579,000 | | OFGS File No. P/1903-28 | | | |
|--|---|-----------------|--------------------------------|-------|-----------|-------------------------------|
| | Applicant Alexander APOLONSKI et al. | | | | | |
| | Filing Date August 18, 2006 | | Group Art Unit | | | |
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| Examiner <i>Sean Hagan</i> | Date Considered <i>October 2007</i> | | | | | |
| EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant. | | | | | | |

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| | | Applicant Alexander APODONSKI et al. | | INVENTION PCT/EP/AT 11 MAY 2006 | | |
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